

Table of Contents

1. **Introduction to Micromechatronics**
 - Fundamentals of micromechatronics
 - MEMS overview and applications
 - Historical development and technological trends
2. **Modeling of Micromechanical Systems**
 - Physical and mathematical modeling
 - Scaling laws
 - Lumped-parameter and distributed-parameter models
3. **Microsensors**
 - Pressure sensors
 - Accelerometers
 - Gyroscopes
 - Thermal sensors
 - Chemical and biological sensors
4. **Microactuators**
 - Electrostatic actuators
 - Piezoelectric actuators
 - Thermal actuators
 - Electromagnetic actuators
5. **Mechanical Microstructures**
 - Beams
 - Plates
 - Membranes
 - Resonators
6. **MEMS Fabrication Technologies**
 - Photolithography
 - Bulk micromachining
 - Surface micromachining
 - Thin-film deposition
 - Etching processes
7. **Dynamic Analysis of Microsystems**
 - Static and dynamic response
 - Natural frequencies
 - Resonance
 - Damping
 - Stability analysis
8. **MATLAB-Based Modeling and Simulation**
 - Numerical methods
 - MATLAB programming
 - System simulation
 - Parameter studies
 - Design optimization
9. **Design Case Studies**
 - MEMS device design examples
 - Model validation
 - Simulation versus experimental results
10. **Future Trends in Micromechatronics**
 - BioMEMS

- Nanoelectromechanical systems (NEMS)
- Smart microsystems
- Emerging applications